



Information Disclosure Statement  
USSN 10/719,008  
October 22, 2004  
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FORM PTO-1449 (Modified)	ATTY DOCKET NO. B-5309 621525-5	U.S. SERIAL NO. 10/719,008
LIST OF PATENTS AND PUBLICATIONS STATEMENT	APPLICANTS Keiji YADA, et al.	
	FILING DATE November 21, 2003	GROUP not yet assigned

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	ISSUE DATE	NAME	CLASS	SUB-CLASS	FILING DATE or 102(e) DATE IF APPROPRIATE
PMK	5,602,899	2/1997	Larson	378	143	
PMK	6,282,263 B1	8/2001	Arndt et al.	378	138	
PMK	2001/0001010 A1	5/2001	Wilkins	378	43	

FOREIGN PATENT DOCUMENTS						
	DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO
PMK	100 29 840	1/2001	DE			abstract
PMK	0 473 227 A2	3/1992	EP			
PMK	735,943	8/1955	GB			
PMK	duplicate Q31 224	6/1974	GB			
PMK	01/15192 A1	3/2001	WO			
PMK	03/065772 A2	8/2003	WO			

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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EXAMINER	DATE CONSIDERED
Elizabeth Keaneey	7/16/05

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	ISSUE DATE	NAME	CLASS	SUB-CLASS	FILING DATE or 102(e) DATE IF APPROPRIATE
BMK	10/719,887		Yada et al.			11/21/2003

FOREIGN PATENT DOCUMENTS						
	DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO
BMK	2004-138460	5/2004	JP			Abstract and partial translation

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
BMK	Nixon, W.C., "High-Resolution X-Ray Projection Microscopy," <i>Proc. Roy. Soc.</i> , A232, pp. 475-485 (1960).
BMK	Yada, K., et al., "Development of Projection X-Ray Microscopy and Its Biological Applications," <i>Bulletin of Aomori Public College</i> , Vol. 1, pp. 2-13 (1996).
BMK	Yada, K., et al., "Development of Soft X-Ray Microscopy," <i>Biophysics</i> , Vol. 33, No. 4, pp. 8-16 (1980).
BMK	Yada, K., et al., "High-Resolution Projection X-Ray Microscopy," <i>Multidimensional Microscopy</i> , Chapter 8, pp. 133-150 (1994).
BMK	Yada, K., et al., "Projection X-Ray Shadow Microscopy Using SEM," <i>Bulletin of the Research Institute for Scientific Measurements</i> , Tohoku University, Vol. 29, No. 1, pp. 25-42 (1980).

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Elizabeth Poaneel	7/16/05

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November 10, 2004  
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U.S. PATENT DOCUMENTS

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	/	/	/	/	/	/

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO
DNY	865,050	4/1961	GB			
DMK	2 131 224	6/1984	GB			

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

DMK	Delong, A., et al., "A New Design Of Field Emission Electron Gun With A Magnetic Lens," <i>Optik</i> , Vol. 81, No. 3, pp. 103-108 (1989).
DMK	Mayo, S.C., et al., "X-Ray Phase-Contrast Microscopy and Microtomography," <i>Optics Express</i> , Vol. 11, No. 19, pp. 2289-2302 (September 2, 2003).

EXAMINER	DATE CONSIDERED
KelliBeth Keaneel	7/16/05

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